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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Application Number	10/559,615
Confirmation Number	1679
Filing Date	December 2, 2005
First Named Inventor	Youichi NANBA
Art Unit	1795
Examiner Name	Tony Sheng Hsiang CHUO
Attorney Docket Number	Q76011

U.S. PATENTS							
Examiner Initials*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
/TC/	1	6.440.610	R1	2002-08-27	Sheem et al.		

U.S. PATENT APPLICATION PUBLICATIONS							
Examiner Cite No Publication Number Kind Code ¹		Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
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FOREIGN PATENT DOCUMENTS								
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EXAMINER SIGNATURE							
Examiner Signature	/Tony Chuo/ (06/04/2010)	Date Considered					

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